#### PATENT APPLICATION

Atty. Docket No.:

2522-042

Serial No .:

10/734,479

Applicant: Filing Date:

Eun-Taek KIM, et al. December 12, 2003

Group:

1746



## INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

# **U.S. PATENT DOCUMENTS**

ef

Document Number

Issue <u>Date</u>

Name

**Class** 

Sub **Class** 

### **FOREIGN PATENT DOCUMENTS**

Exam <u>Init</u>	Ref	Document Number	Publication <u>Date</u>	Country	Name
A		09-148255	June 6, 97	Japan	Tomomi, et al.
- Of		11-222679	Aug. 17, 99	Japan	Toshiyuki, et al.
4	· .	2000-143213	May 23, 00	Japan	Chitoshi, et al.

#### **OTHER DOCUMENTS**

Exam <u>Init</u>	Ref	Author, Title, Date, Pertinent Pages, Etc.)
Ag		English language abstract of Japanese Publication No. 09-148255
14		English language abstract of Japanese Publication No. 11-222679
-	***	English language abstract of Japanese Publication No. 2000-143213

Examiner: Scharce State

Date Considered: 3/14/64

Applicant:

Eun-Taek Kim, et al.

Filing Date:

December 12, 2003

Art Unit:

not yet assigned

Serial No.

not yet assigned

Examiner:

not yet assigned

Title:

METHOD FOR CLEANING A DEPOSITION CHAMBER AND DEPOSITION

APPARATUS FOR PERFORMING IN SITU CLEANING

#### INFORMATION DISCLOSURE CITATION FORM PTO-1449 (Modified)

FOREIGN PATENT DOCUMENTS

Exam <u>Init</u>

Document Number

Publication

<u>Date</u>

Country

<u>Name</u>

<u>Ref</u>

JP11222679

8/17/1999

Japan

Toshiyuki et al.

**OTHER DOCUMENTS** 

Exam

<u>Init</u> Ref Author, Title, Date, Pertinent Pages, Etc.)

English language Abstract from Japanese Patent Publication No. JP11222679 published 8/17/1999.

Examiner: <u>Geliaudh</u>

Date Considered: <u>3/14/06</u>